

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF:

CEM BASCERI ET AL.

APPLICATION NO.:

10/665,099

FILED:

SEPTEMBER 17, 2003

For:

MICROFEATURE WORKPIECE PROCESSING APPARATUS AND METHODS FOR CONTROLLING **DEPOSITION OF MATERIALS ON** MICROFEATURE WORKPIECES

EXAMINER: WILLIAM M.

BREWSTER

ART UNIT:

2823

CONF. No: 6145

Amendment Under 37 C.F.R. § 1.312

Mail Stop Issue Fee Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The present communication responds to the Examiner's Amendment appearing in the Notice of Allowance mailed September 30, 2005 in the above-identified application. Please amend the application as follows:

Amendments to the Specification begin on page 2.